FORM PTO-1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	Complete if Known	
		Application Number	Unknown
		Filing Date	October 10, 2003
	INFORMATION DISCLOSURE STATEMENT BY APPLICANT	First Named Inventor	Easter, et al.
		Group Art Unit	Unknown
		Examiner Name	Unknown
Sheet 1 of 1		Attorney Docket Number	27757-901

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Examiner Signature		Date Considered	8/16/05

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

FORM PTO-1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	Complete if Known	
	INFORMATION DISCLOSURE STATEMENT BY APPLICANT	**Application Number**	10/684358
		Filing Date	10/10/2003
		First Named Inventor	Easter, et al
		Group Art Unit	1765
		Examiner Name	Unknown
Sheet 1 of 1		Attorney Docket Number	27757-901

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	AR						

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	AV						
	AW						

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	AX	
	AY	
	AZ	

Examiner Signature		Date Considered	8/17/05

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